

December 31, 2003

ATTORNEY DOCKET NO. 09407.0001

CUSTOMER NO. 22,852

Mail Stop Patent Application

Commissioner for Patents P.O. Box 1450 **Alexandria, VA 22313-1450**

New U.S. Patent Application

Title: METHOD FOR FABRICATING TRANSISTOR OF SEMICONDUCTOR DEVICE

Inventor and Address:

Jeong Ho PARK Gyeonggi-do, Korea

Sir:

We enclose the following papers for filing in the United States Patent and Trademark Office in connection with the above patent application.

- Application- 26 pages, including 3 independent claims and 31 claims total. 1.
- 2. Drawings- 8 sheets of drawings containing 22 figures
- 3. The filing fee is calculated as follows:

Basic Application Filing Fee					\$770	\$	\$770.00
	Number of Claims		Basic	Extra Claims			
Total Claims	31	-	20	11	x \$18		198.00
Independent Claims	3	-	3		x \$86		
☐ Presentation of Multiple Dep. Claim(s) +\$290							
Subtotal						\$	968.00
Reduction by 1/2 if small entity						-	
TOTAL APPLICATION FILING FEE						\$	968.00

4. A check for \$968.00 is enclosed.

This application is being filed under the provisions of 37 C.F.R. § 1.53(f). Applicant awaits notification from the Patent and Trademark Office of the time set for filing the Declaration.

Applicant claims the right to priority based on Korean Patent Application No. 10-2003-0075431, filed October 28, 2003, Korean Patent Application No. 10-2003-0075440, filed October 28, 2003 and Korean Patent Application No. 10-2003-0078770, filed November 7, 2003.

Please address all correspondence with respect to this application to:

Finnegan, Henderson, Farabow, Garrett & Dunner, L.L.P. 1300 I Street, N.W. Washington, D.C. 20005-3315

Please accord this application an application number and filing date.

The Commissioner is hereby authorized to charge any additional filing fees due and any other fees due under 37 C.F.R. § 1.16 or §1.17 during the pendency of this

application to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,

GARREDT & DUNNER L.L.P.

Richard V. Burgujian

Reg. No. 31,744

RVB/FPD/dvg Enclosures

ERNEST F. CHAPMAN Reg. No. 25,961